U.S. UTILITY Patent Application

PATENT NUMBER and ISSUE DATE

APPL. NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10082658	10/19/2001	378	119	2882	Thomas, C

APPLICANTS: Richardson Martin;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CIP OF 09/881,620 06/14/2001

AND CLAIMS BENEFIT OF 60/242,102 10/20/2000   verified CT

** FOREIGN APPLICATIONS VERIFIED: none CT

PG-PUB	DO NOT PUBLISH ☐	RESCIND ☐	
Foreign priority claimed	☐ yes ☑ no	ATTORNEY DOCKET NO	
35 USC 119 conditions met	☐ yes ☑ no		
Verified and Acknowledged Examiner's initials		UCF-306CIP	

TITLE : EUV, XUV, and X-ray wavelength sources created from laser plasma produced from liquid metal solutions, and nano-size particles in solutions

U.S.DEPT. OF COMM./PAT.& TM-PTO-436L(Rev. 12-94)

NOTICE OF ALLOWANCE MAILED

7/02/03

Courtney Thomas
Assistant Examiner

ISSUE FEE

Amount Due	Date Paid
$960	

DAVID V. BRUCE
PRIMARY EXAMINER

Primary Examiner

PREPARED FOR ISSUE

☐ TERMINAL DISCLAIMER

TOTAL CLAIMS

Total Claims	Print Claim for
28	1

DRAWING

Sheets Drwg.	Figs. Drwg.	Print Fig.
6	8	2,4

Application Examiner 7/8/03

FILED WITH: ☑ DISK (CRF)   ☐ CD-ROM
(Attached in pocket on right inside flap)